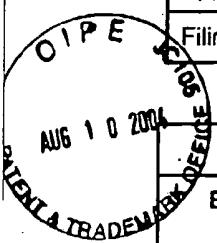


OMB No. 0651-0011
INFORMATION DISCLOSURE CITATION

Atty. Docket No.	09140-0014-00000	Appln. No.	09/903,081
Applicant	Demaray et al.		
Filing Date	July 10, 2001	Group:	1731



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	2001/0027159	Oct. 04, 2001	Kaneyoshi	501	152	
	2002/0106297	Aug. 08, 2002	Ueno et al.	419	12	
	2003/0019326	Jan. 30, 2003	Han et al.	45	245	
	2003/0063883	Apr. 3, 2003	Demaray et al.	385	129	
	2003/0175142	Sep. 18, 2003	Milonopoulou et al.	419	49	
	4,437,966	Mar. 7, 1961	Hope et al	204	298	
	4,915,810	Apr. 10, 1990	Kestigian et al.	204	298.04	
	4,978,437	Dec. 18, 1990	Wirz	204	192	
	5,085,904	Feb. 4, 1992	Deak et al.	428	35.7	
	5,107,538	Apr. 21, 1992	Benton et al.	385	130	
	5,119,460	Jun. 2, 1992	Bruce et al.	385	142	
	5,174,876	Dec. 29, 1992	Buchal et al.	427	526	
	5,200,029	Apr. 6, 1993	Bruce et al.	156	657	
	5,206,925	Apr. 27, 1993	Nakazawa et al.	385	142	
	5,237,439	Aug. 17, 1993	Misono et al.	359	74	
	5,225,288	Jul. 6, 1993	Beeson et al.	428	475.5	
	5,252,194	Oct. 12, 1993	Demaray et al.	204	298	
	5,303,319	Apr. 12, 1994	Ford et al.	385	131	
	5,381,262	Jan. 10, 1995	Arima et al.	359	341	
	5,427,669	Jun. 27, 1995	Drummond	204	298.2	

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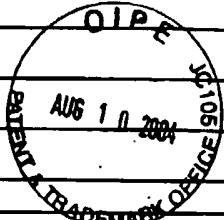
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	5,555,127	Sep. 10, 1996	Abdelkader et al.	359	341		
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	5,565,071	Oct. 15, 1996	Demaray et al.	204	192		
	5,603,816	Feb. 18, 1997	Demaray et al.	204	298		
	5,607,789	Mar. 4, 1997	Treger et al.	429	90		
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	5,654,054	Aug. 5, 1997	Tropsha et al.	428	36.6		
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	5,718,813	Feb. 17, 1998	Drummond	204	192.2		
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	5,792,550	Aug. 11, 1998	Phillips et al.	428	336		
	5,831,262	Nov. 3, 1998	Greywall et al.	250	227		
	5,841,931	Nov. 24, 1998	Foresi et al.	385	131		
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	5,900,057	May. 4, 1999	Buchal et al.	117	109		

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	5,966,491	Oct. 12, 1999	DiGiovanni	385	127	
	5,977,582	Nov. 2, 1999	Fleming et al.	257	310	
	6,001,224	Dec. 14, 1999	Drummond	204	192.12	
	6,024,844	Feb. 15, 2000	Drummond et al.	204	192.12	
	6,051,114	Apr. 18, 2000	Yao et al.	204	192.3	
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	6,058,233	May 2, 2000	Dragone	385	46	
	6,080,643	Jun. 27, 2000	Noguchi et al.	438	487	
	6,093,944	Jul. 25, 2000	VanDover	257	310	
	6,106,933	Aug. 22, 2000	Nagai et al.	428	212	
	6,146,225	Nov. 14, 2000	Sheats et al.	445	24	
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	6,248,291 B1	Jun. 19, 2001	Nakagama et al.	419	46	
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